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	First Named Inventor David		A. Cathey	
	Art Unit		2879	
	Examiner Name	A. Pat	tel	
	Attorney Docket Numb	er	2269-7129.2US(95-0582.02/	
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/AP/	5	Evtukh, et al. "Parameters of the Tip Arrays Covered by Low Work Function Layers," J. Vac. Sci Tech. B 14 (3), pp. 2130-2134, (Pub. May-June 1996).					
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